AMENDMENTS

In the Claims

This listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Currently Amended) A computer-implemented method of automatic carrier transfer, comprising using a computer to perform the steps of:

executing a data verification procedure after a first process operation of a plurality of wafers according to a manufacturing execution system database and obtaining a verification result, wherein the data verification procedure verifies the data between the wafers and the MES database;

<u>dynamically</u> producing a carrier transfer sub-route of the wafers according to the verification result;

executing the carrier transfer sub-route of the wafers; and executing a second process operation for the wafers.

- 2. (Cancelled)
- 3. (Cancelled)
- 4. (Original) The computer-implemented method as claimed in claim 1, wherein executing the carrier transfer sub-route further comprises updating the MES database.
- 5. (Original) The computer-implemented method as claimed in claim 1, wherein the carrier transfer sub-route is enabled by transferring the wafers from a first carrier to a second carrier.

- 6. (Original) The computer-implemented method as claimed in claim 1, wherein the carrier transfer sub-route is enabled by splitting the wafers in the first carrier and transferring the split lots to at least two carriers.
- 7. (Original) The computer-implemented method as claimed in claim 1, wherein the first process operation and the second process operation are stored in a first database.
- 8. (Currently Amended) The computer-implemented method as claimed in claim [[1]] 7, wherein the carrier transfer sub-route is stored in a second database.
- 9. (Currently Amended) A storage medium for storing a computer program providing a method of automatic carrier transfer, comprising using a computer to perform the steps of:

executing a data verification procedure after a first process operation of a plurality of wafers according to a manufacturing execution system database and obtaining a verification result, wherein the data verification procedure verifies the data between the wafers and the MES database;

dynamically producing a carrier transfer sub-route according to the verification result; executing the carrier transfer sub-route of the wafers; and executing a second process operation for the wafers.

- 10. (Cancelled)
- 11. (Cancelled)
- 12. (Original) The storage medium as claimed in claim 9, wherein the step of executing the carrier transfer sub-route further comprises updating the MES database.

- 13. (Original) The storage medium as claimed in claim 9, wherein the carrier transfer sub-route is enabled by transferring the wafers from a first carrier to a second carrier.
- 14. (Original) The storage medium as claimed in claim 9, wherein the carrier transfer sub-route is enabled by splitting the wafers in the first carrier and transferring the split lots to at least two carriers.
- 15. (Original) The storage medium as claimed in claim 9, wherein the first process operation and the second process operation are stored in a first database.
- 16. (Currently Amended) The storage medium as claimed in claim [[9]] 15, wherein the carrier transfer sub-route is stored in a second database.
- 17. (Currently Amended) A system of automatic carrier transfer, comprising:
 - a first execution module, executing a data verification procedure after a first process

 operation of a plurality of wafers according to a manufacturing execution system

 database and obtaining a verification result, wherein the data verification

 procedure verifies the data between the wafers and the MES database;
 - a sub-route production module, coupled to the first execution module, <u>dynamically</u> producing a carrier transfer sub-route according to the verification result;
 - a sub-route execution module, coupled to the sub-route production module, executing the carrier transfer sub-route of the wafers; and
 - a second execution module, coupled to the sub-route execution module, executing a second process operation for the wafers.

18. (Cancelled)

- 19. (Cancelled)
- 20. (Currently Amended) The system as claimed in claim 17, wherein the sub-route execution module further updates the <u>MES</u> database of <u>MES</u>.
- 21. (Original) The system as claimed in claim 17, wherein the carrier transfer sub-route is enabled by transferring the wafers from a first carrier to a second carrier.
- 22. (Original) The system as claimed in claim 17, wherein the carrier transfer sub-route is enabled by splitting the wafers in the first carrier and transferring the split lots to at least two carriers.
- 23. (Original) The system as claimed in claim 17, wherein the first process operation and the second process operation are stored in a first database.
- 24. (Currently Amended) The system as claimed in claim [[17]] <u>23</u>, wherein the carrier transfer sub-route is stored in a second database.
- 25. 32. (Cancelled)

33. (New) A computer-implemented method of automatic carrier transfer, comprising using a computer to perform the steps of:

executing a data verification procedure after a first process operation of wafers according to a manufacturing execution system database to obtain a verification result, the data verification procedure verifying data between the wafers and the MES database;

dynamically selecting a carrier transfer sub-route of the wafers according to the verification result;

executing the carrier transfer sub-route of the wafers; and

executing a second process operation for the wafers;

wherein the first process operation and the second process operation are stored in a first database and are selected for processing of the wafers prior to executing the first process operation; and

wherein the carrier transfer sub-route is stored in a second database.